Attorney Docket No. USS-18302/16

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2800

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Subhendu Guha et al.

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Serial No.: 10/765,435

Group Art Unit: 2822

Filing Date: January 27, 2004

Examiner: Thanh Y. Tran

For: METHOD FOR DEPOSITING HIGH-QUALITY MICROCRYSTALLINE SEMICONDUCTOR MATERIALS

## RESPONSE UNDER RULE 116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This response is being sent in reply to the Office Action mailed June 7, 2006, the deadline for response thereto being September 7, 2006.